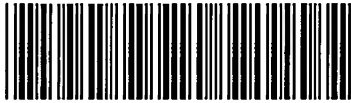


**Search Notes**

Application/Control No.

10/775,795

Examiner

Steven D. Maki

Applicant(s)/Patent under  
Reexamination

HEINEN, RICHARD

Art Unit

1733

**SEARCHED**

Class	Subclass	Date	Examiner
152	209.2		
	209.8		
	209.9		
	209.15		
	209.18		
	209.28		
	902		
	903		
updated	above	10/1/2006	<i>SM</i>

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
none	10/1/2006	<i>SM</i>